REPLY UNDER 37 CFR 1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No. 10/710,827 Conf. No. 4826

In Re Application of: MacDonald Art Unit: 2822

Filed: 08/05/2004 Dkt. #: FIS920040163US1 (IBMF-0064)

Cust. No.: 45094 Examiner: Duong, Khanh B.

Title: METHOD OF FORMING A POLISHING INHIBITING LAYER USING A SLURRY HAVING AN ADDITIVE

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AFTER FINAL AMENDMENT

Sir:

I. INTRODUCTORY COMMENTS

In response to the Final Office Action of March 21, 2007, please reconsider the abovereferenced patent application in light of the following remarks:

The Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 9 of this paper.